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RESPONSE UNDER 37 CFR 1.416
EXPEDITED PROCEDURE
EXAMINING GROUP 2813

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: E. Kielen
Toshiyuki SHIGARAKI)	
	:	Group Art Unit: 2813
Application No.: 09/851,158)	
	:	
Filed: May 9, 2001)	
	:	
For: SEMICONDUCTOR MANUFACTURING)		July 15, 2003
APPARATUS AND METHOD OF	:	
MANUFACTURING SEMICONDUCTOR)		
DEVICES	:	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.


Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to

charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
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